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03500.015497.

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

AKIHIRO KIMURA ET AL.

Application No.: 09/888,594

Filed: June 26, 2001

For: ELECTRON SOURCE  
MANUFACTURING  
APPARATUS

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Examiner: Sumati Krishnan  
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May 18, 2004

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

a.) Introductory Comments:

Sir:

In response to the Office Action dated February 25, 2004, kindly amend the  
subject application as follows: